

Tsoo-240



Application no. 09/769,812

CB

May 3, 2004

TO: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FROM: George O. Saile, Reg. No. 19,572
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SUBJECT: Serial #: 09/769,812
File Date: 1/26/01
Inventor: Li-Te Lin, Li-Chih Chao, Chia-Shiung Tsai
Examiner: Lan Vinh
Art Unit: 1765
Title: An Organic Low K Dielectric Etch With NH3 Chemistry
Customer Number 28112

AMENDMENT AFTER ALLOWANCE

This is in response to the Office Action dated 4/23/04. Please amend the above-identified application for patent as follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231 on May 4, 2004.

Signature S. B. Ackerman
Stephen B. Ackerman, Reg. No. 37,761

Date: 5/4/04

Amendments to the Specification begin on page 3 of this paper.

Remarks/Arguments begin on page 4 of this paper.